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# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Smith et al.  
Appl. No. 10/765,223  
Filed: January 26, 2004  
For: REFERENCE WAFER AND  
PROCESS FOR  
MANUFACTURING SAME  
Art Unit: 1756  
Examiner: Young, Christopher G.

hereby certify that this correspondence and the attached papers are being deposited with the United States Postal Service with sufficient postage as first class mail on the date indicated below in an envelope addressed to:

Commissioner for Patents  
U.S. Patent and Trademark Office  
P.O. Box 1450  
Alexandria, VA 22313-1450

1/6/06 Date Michelle Melendez Signature

## TRANSMITTAL LETTER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Enclosed are the following documents:

- 1) Transmittal Letter;
- 2) Response to Restriction Requirement;
- 3) Return Postcard for this transmittal.



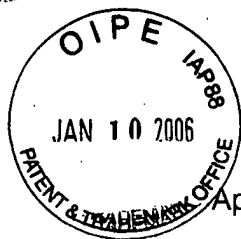
The Commissioner is hereby authorized to charge any fee, including any submitted herewith if the attached check(s) is in the wrong amount or otherwise improper or missing, that may be due in connection with this and the attached papers, or with this application during its entire pendency to or to credit any overpayment to Deposit Account No. 50-1213. A duplicate of this sheet is enclosed.

Respectfully submitted,  
HELLER EHRMAN LLP

By: David A. Hall  
David A. Hall  
Registration No. 32,233

### Address all correspondence to:

David A. Hall  
HELLER EHRMAN LLP  
4350 La Jolla Village Drive, 7<sup>th</sup> Floor  
San Diego, CA 92122-1246  
Telephone: (858) 450-8400 Facsimile: (858) 450-8499  
Email: david.hall@hellerehrman.com



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1/16/06  
Date

Michelle Malend  
Signature

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 8, 2005 containing a  
restriction requirement, Applicant hereby elects Group II (Claims 30-41), drawn to a  
method of using a reference wafer.

The Examiner required election between Group I (Claims 28 and 29) and  
Group II (Claims 30-41). Applicant reserves the right to file continuing applications  
directed to the non-elected claims.

Respectfully submitted,  
HELLER EHRMAN LLP

By: David A. Hall

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